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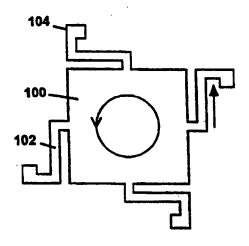
INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

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(21) International Application Number: PCT/U (22) International Filing Date: 1 April 1999 (30) Priority Data: 09/056,975 8 April 1998 (08.04.98) (63) Related by Continuation (CON) or Continuation-(CIP) to Earlier Application US 09/056,5 Filed on 8 April 1998 (71) Applicant (for all designated States except US): INC. [US/US]; Suite 501, 354 Congress Street, B 02110–1237 (US). (72) Inventor; and (75) Inventor/Applicant (for US only): MILES, Mark, W Suite 501, 354 Congress Street, Boston, MA 02110–2804 (US). (74) Agent: FEIGENBAUM, David, L.; Fish & Richar 225 Franklin Street, Boston, MA 02110–2804 (US)	in-Part 975 (CO) (08.04.9 ETALC oston, M	Published With international search report. Before the expiration of the time limit for amending the claim and to be republished in the event of the receipt of amendments (88) Date of publication of the international search report: 29 December 1999 (29.12.99

(54) Title: INTERFEROMETRIC MODULATION OF RADIATION

(57) Abstract

The invention features an interferometric modulator comprising a cavity defined by two walls. At least two arms connect the two walls to permit motion of the walls relative to each other. The two arms are configured and attached to a first one of the walls in a manner that enables mechanical stress in the first wall to be relieved by motion of the first wall essentially within the plane of the first wall.



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INTERNATIONAL SEARCH REPORT

Internatic Application No PCT/US 99/07271

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According to	International Patent Classification (IPC) or to both national classification	n and IPC
B. FIELDS	SEARCHED	
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C. DOCUME	ENTS CONSIDERED TO BE RELEVANT	
Category *	Citation of document, with indication, where appropriate, of the relevant	ant passages Relevant to claim No.
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Α	page 33, line 20 -page 34, line 19 28	5; figure 14
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X Fur	ther documents are listed in the continuation of box C.	X Patent family members are listed in annex.
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Internat Application No PCT/US 99/07271

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International application No. PCT/US 99/07271

INTERNATIONAL SEARCH REPORT

Box I Observations where certain claims were found unsearchable (Continuation of item 1 of first sheet)
This International Search Report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:
Claims Nos.: because they relate to subject matter not required to be searched by this Authority, namely:
2. Claims Nos.: because they relate to parts of the International Application that do not comply with the prescribed requirements to such an extent that no meaningful International Search can be carried out, specifically:
3. Claims Nos.: because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).
Box II Observations where unity of invention is lacking (Continuation of item 2 of first sheet)
This International Searching Authority found multiple inventions in this international application, as follows:
As all required additional search fees were timely paid by the applicant, this International Search Report covers all searchable claims.
2. As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.
3. As only some of the required additional search fees were timely paid by the applicant, this International Search Report covers only those claims for which fees were paid, specifically claims Nos.:
4. No required additional search fees were timely paid by the applicant. Consequently, this International Search Report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.: 1-15,23,24
Remark on Protest The additional search fees were accompanied by the applicant's protest. No protest accompanied the payment of additional search fees.

FURTHER INFORMATION CONTINUED FROM PCT/ISA/ 210

1. Claims: 1-15,23,24

An interferometric modulator comprising a cavity defined by two walls wherein the first wall is movable relative to the second wall and within the plane of the first wall

2. Claims: 16-18

Interferometric modulator comprising three walls and control circuitry for driving at least one of three walls

3. Claims: 19-20

an interference modulator comprising spacers mounted to form part of one of the walls

4. Claims: 21,22,25

Interference modulator comprising means to control the response time of the modulator

5. Claim: 26

Interferomtric modulator comprising a charge deposition mitigating device

6. Claims: 27-32

An interferometric modulator, comprising walls and a support and at least one of the walls or the support comprising at least two materials

7. Claims: 33-38,44-48

A method of etching and patterning a microelectromechanical structure

8. Claims: 39-43

a method of making arrays of microelectromechanical structure on a production line

INTERNATIONAL SEARCH REPORT

intermation on patent family members

Interna 1 Application No PCT/US 99/07271

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